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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/078,831	02/18/2002	Sanh Dang Tang	MIO 0018 V2/96-1138.03	8095
75	590 03/03/2003			
Killworth, Gottman, Hagan & Schaeff, L.L.P. One Dayton Centre, Suite 500 Dayton, OH 45402-2023			EXAMINER	
			ESTRADA, MICHELLE	
			ART UNIT	PAPER NUMBER
			2823	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)	(in				
	•	10/078,831	TANG, SANH DANG	TANG, SANH DANG				
•	Office Action Summary	Examiner	Art Unit					
		Michelle Estrada	2823					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply								
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). - Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).								
Status 1)□	Responsive to communication(s) filed on							
2a)□		This action is non-final.						
3)	, -		atters prosecution as to the n	nerits is				
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213. Disposition of Claims								
4)⊠ Claim(s) <u>1-8</u> is/are pending in the application.								
4	a) Of the above claim(s) is/are with	ndrawn from consideration.						
5) Claim(s) is/are allowed.								
6)⊠ Claim(s) <u>1-8</u> is/are rejected.								
7)	Claim(s) is/are objected to.							
8)	Claim(s) are subject to restriction a	nd/or election requirement.						
Application	on Papers							
9)[] 7	he specification is objected to by the Exar	miner.						
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.								
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.								
If approved, corrected drawings are required in reply to this Office action.								
12) The oath or declaration is objected to by the Examiner.								
Priority under 35 U.S.C. §§ 119 and 120								
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).								
a) All b) Some * c) None of:								
	1. Certified copies of the priority documents have been received.							
	2. Certified copies of the priority documents have been received in Application No							
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.								
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).								
a) ☐ The translation of the foreign language provisional application has been received. 15) ☒ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.								
Attachment								
2) Notice	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948 nation Disclosure Statement(s) (PTO-1449) Paper No	5) Notice of	Summary (PTO-413) Paper No(s). Informal Patent Application (PTO-15)					

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DETAILED ACTION

Claim Objections

Claims 4 and 8 are objected to because of the following informalities: In line 2, it appears that "matter" should be replaced with --material--. Appropriate correction is required.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-6 and 8 are rejected under 35 U.S.C. 103(a) as being unpatentable over the combination of Blalock (5,320,981) and Wu (5,940,731).

Blalock discloses a substrate (12); a layer of dielectric material (14) formed on at least a portion of said substrate; a layer of conductive material (10) formed within said layer of dielectric material; a layer of etch resistant material such as a photoresist; at least a portion of said layer of dielectric material and said layer of etch resistant material each having openings therein defining a via, said via exposing at least a portion of said layer of conductive material (Col. 4, lines 30-35 and Fig. 2); wherein said layer of conductive material contacts at least a portion of said substrate.

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Wu does not disclose a layer of hard mask material formed on at least a portion of said layer of dielectric material; said layer of dielectric material including a pair of shoulders having hard mask material thereon, and said layer of hard mask material having a pair of facets.

Wu discloses a dielectric layer (14) having a via; a hard mask layer (28) formed on at least a portion of said layer of dielectric material; said layer of dielectric material including a pair of shoulders (34) having hard mask material thereon of polycrystalline silicon, and said layer of hard mask material having a pair of facets (See Fig. 6); and an interconnect material (72) in said via.

It would have been within the scope of one of ordinary skill in the art to combine the teachings of Blalock and Wu to enable formation of the interconnect structure.

Claim 7 is rejected under 35 U.S.C. 103(a) as being unpatentable over the combination of Blalock (5,320,981) and Wu (5,940,731) as applied to claims 1-6 and 8 above, and further in view of Trivedi et al. (5,847,463).

The combination of Blalock and Wu does not disclose that the hard mask material comprises a titanium-tungsten alloy.

Trivedi et al. disclose titanium-tungsten alloy as a suitable material for a hard mask in an interconnect structure (Col. 5, line 33-37).

It would have been within the scope of one of ordinary skill in the art to combine the teachings of Blalock, Wu and Trivedi et al. to enable formation of the hard mask layer. Application/Control Number: 10/078,831

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Michelle Estrada whose telephone number is (703) 308-0729. The examiner can normally be reached on Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 703-306-2794. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

George Fourson
Primary Examiner
Art Unit 2823

MEstrada

February 13, 2003